

Density Dependence of the Excitation Gap in Si/SiGe Bilayers

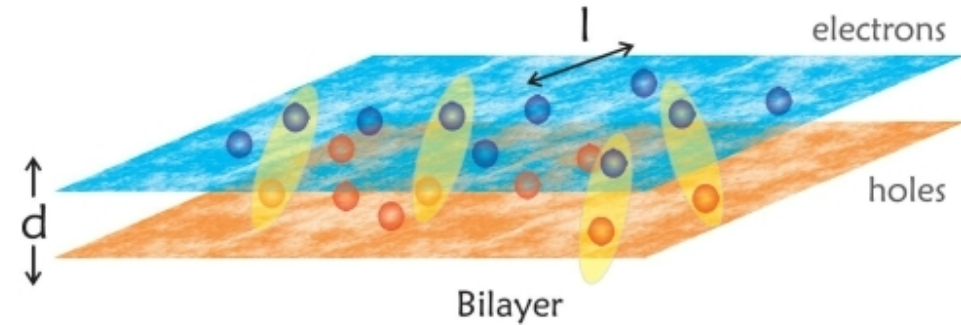
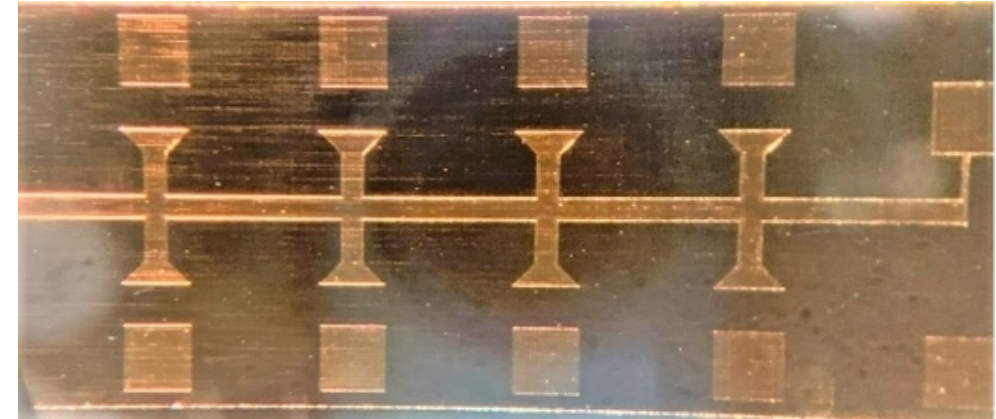
Session: Integer Quantum Hall Effect: Transport Phenomena

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3/16/2022

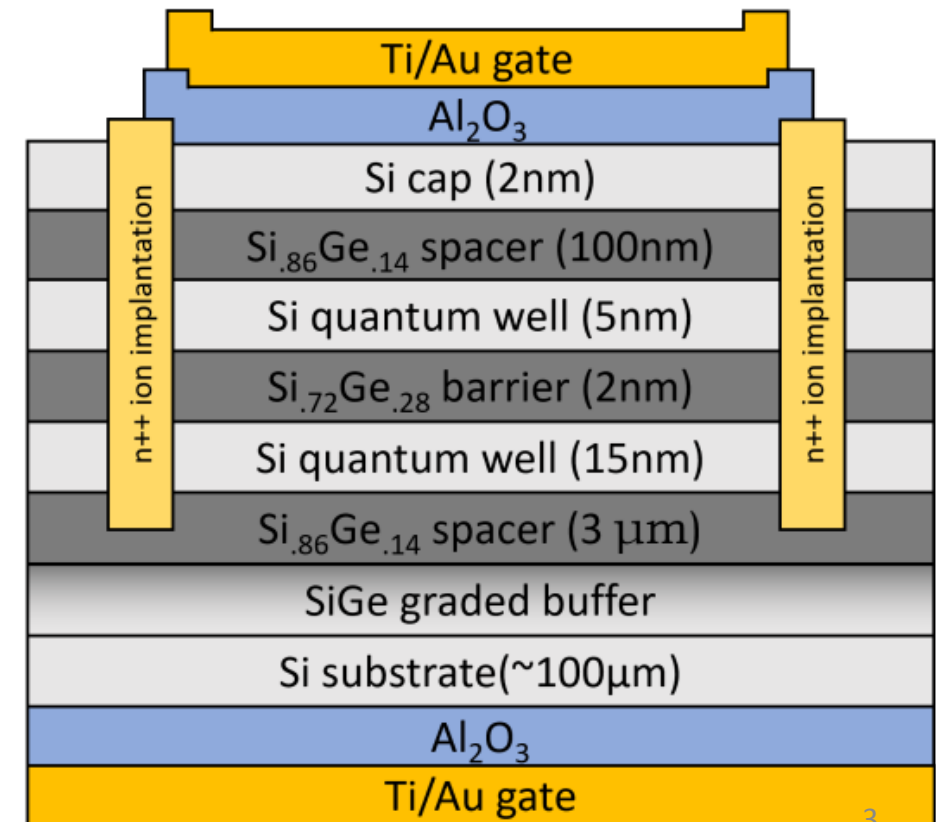
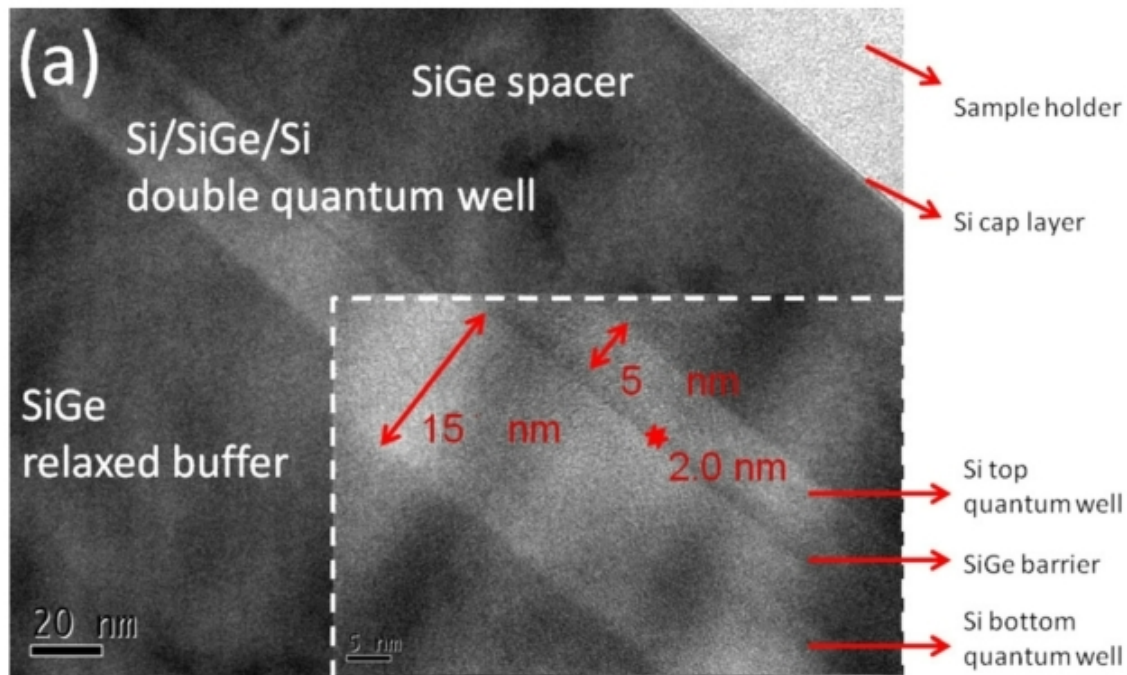
Motivation

- Si-based heterostructures – CMOS technology
- SiGe-based heterostructures
 - Undoped structure with high μ /low disorder
 - ^{28}Si (nuclear spin free) – decoherence
 - Quantum computing
- Exciton Condensation
 - Resistanceless Transistors
- Valley Splitting (VS)
 - Valleytronics & Si qubit



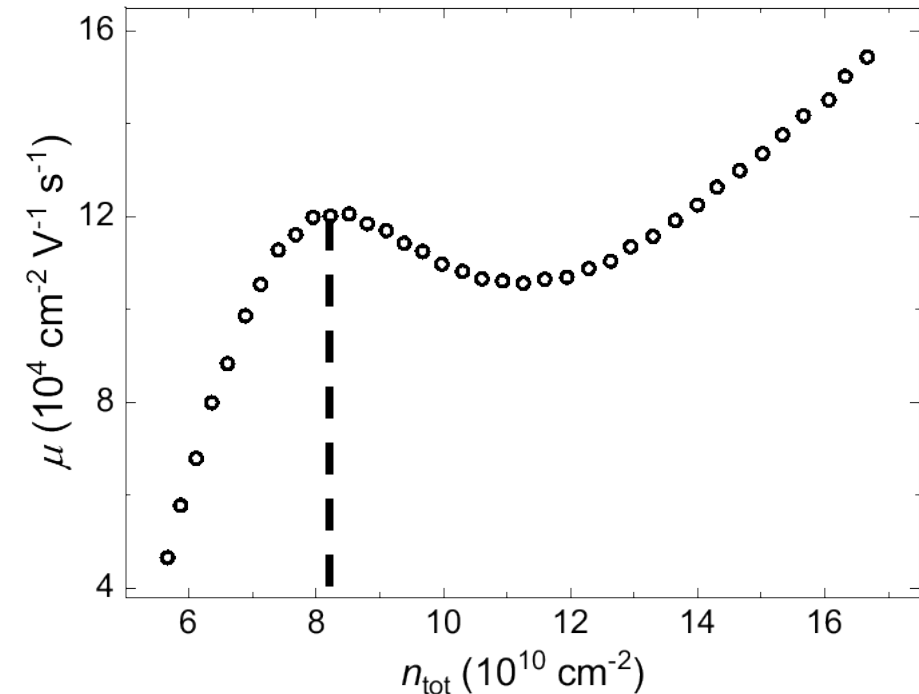
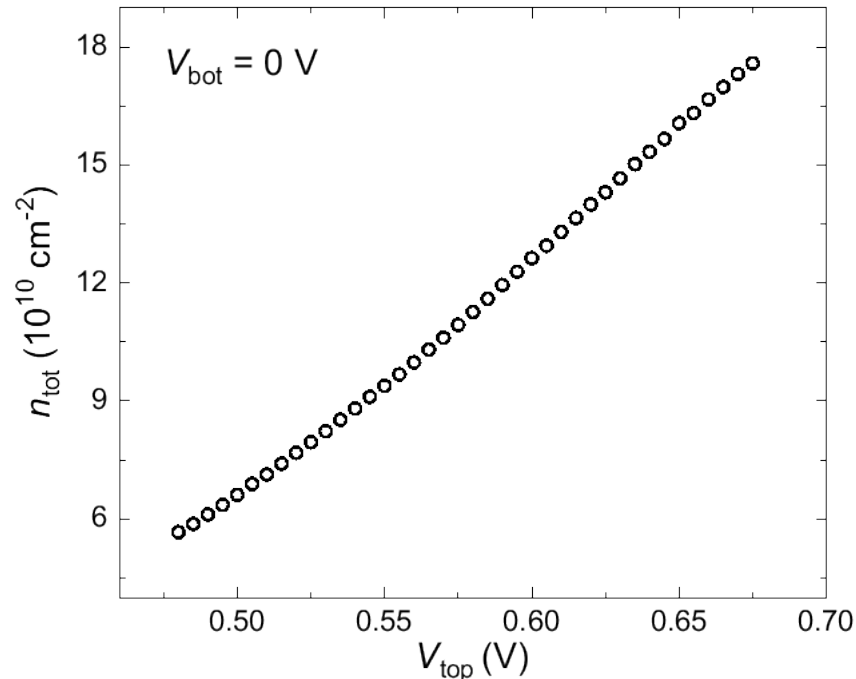
Growth & Fabrication

- Undoped & Assymmetric Double Quantum Well
- HFET w/ Hall bar geometry patterned using standard fabrication processes
- Front and **BACK** gate capabilities
- Hall densities from $6.8 \times 10^{10} \text{ cm}^{-2}$ to $3.42 \times 10^{11} \text{ cm}^{-2}$
- Hall mobility corresponding to $3.08 \times 10^5 \text{ cm}^2/(\text{V} \cdot \text{s})$



Bilayer Behavior

- The mobility increases with Hall density until the crossover density, $8.22 \times 10^{10} \text{ cm}^{-2}$. ($V_{\text{top}} = 0.53 \text{ V}$)
- The mobility then drops to a minimum of $1.06 \times 10^5 \text{ cm}^2/(\text{V} \cdot \text{s})$ due to inter-layer scattering and indicates the bilayer system was formed.

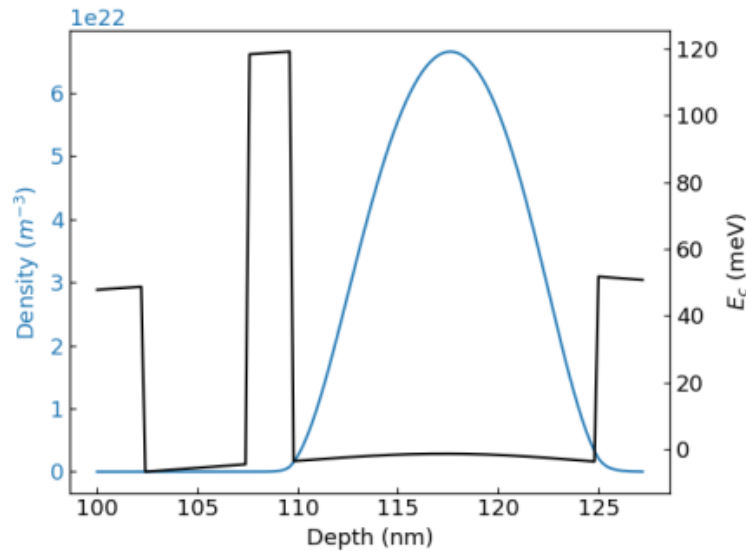


Schrödinger-Poisson Simulations

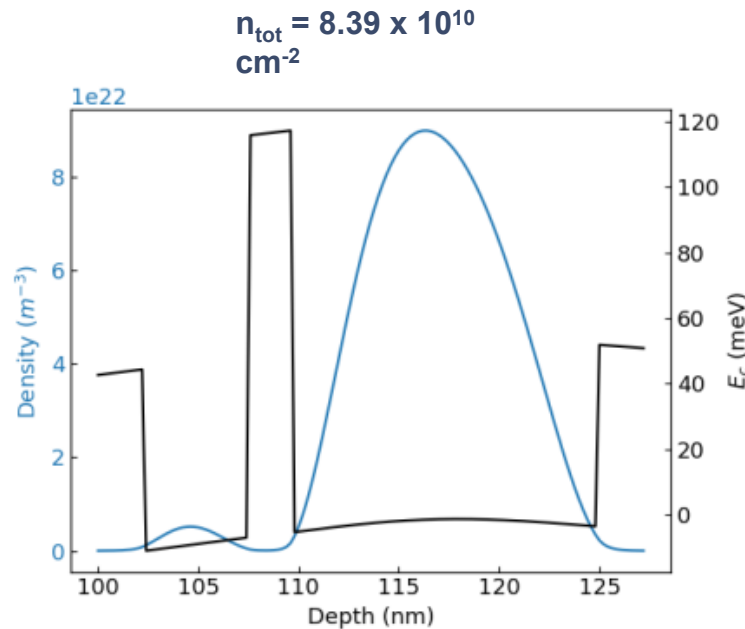
Results

UF

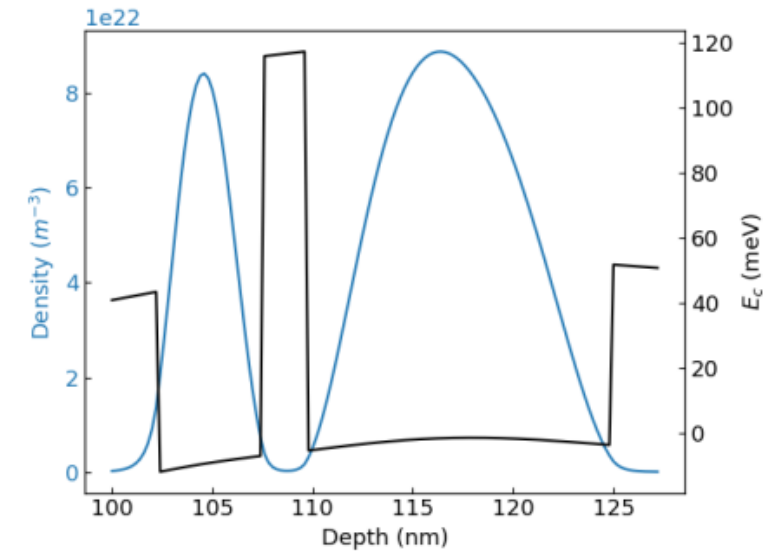
- An iterative, self-consistent SP simulation reproduces $n_{\text{crossover}}$ at $8.22 \times 10^{10} \text{ cm}^{-2}$
 - Band gaps were artificially increased at the heterostructure's spacers
 - Nominal growth parameters
- $\Delta_{S,AS} = E_{AS} - E_S$ (Single Electron Tunnel Splitting)



$$n_{\text{tot}} = 6 \times 10^{10} \text{ cm}^{-2}$$



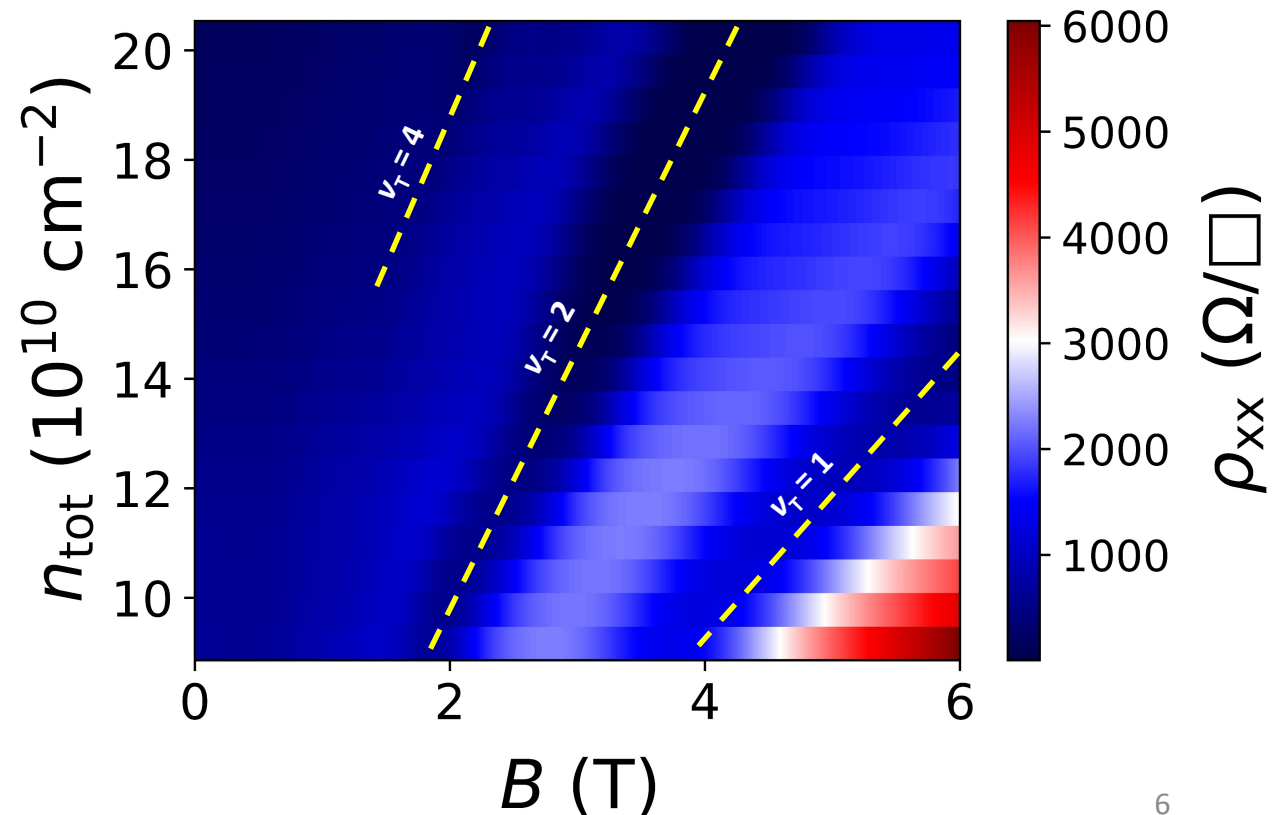
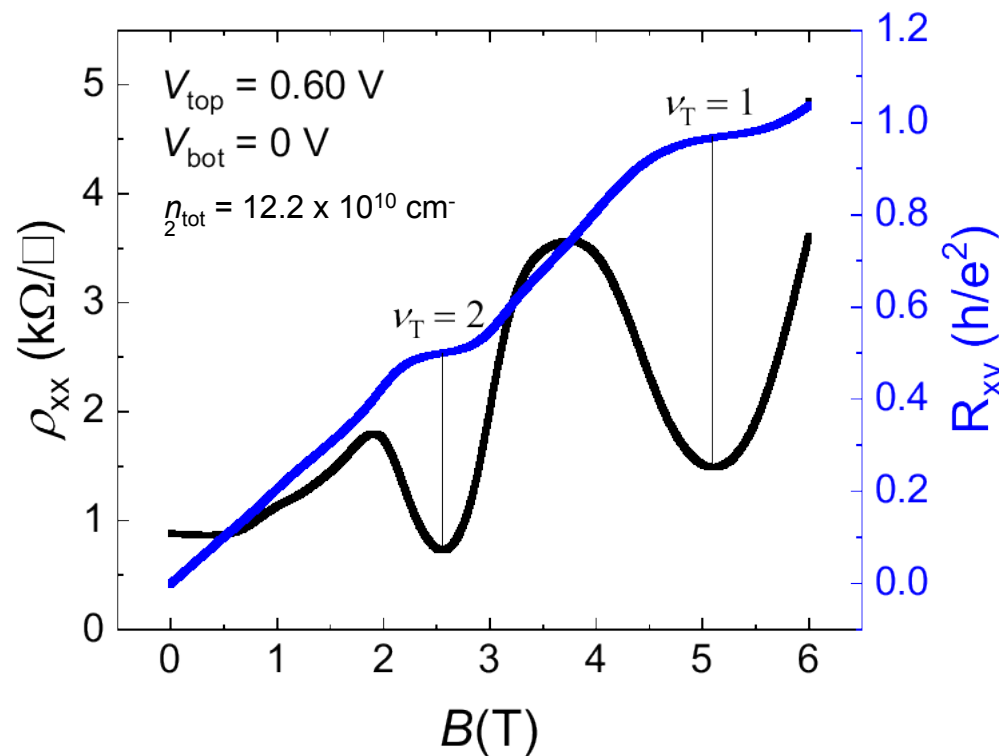
$$n_{\text{tot}} = 8.39 \times 10^{10} \text{ cm}^{-2}$$



$$n_{\text{tot}} = 10.9 \times 10^{10} \text{ cm}^{-2}$$

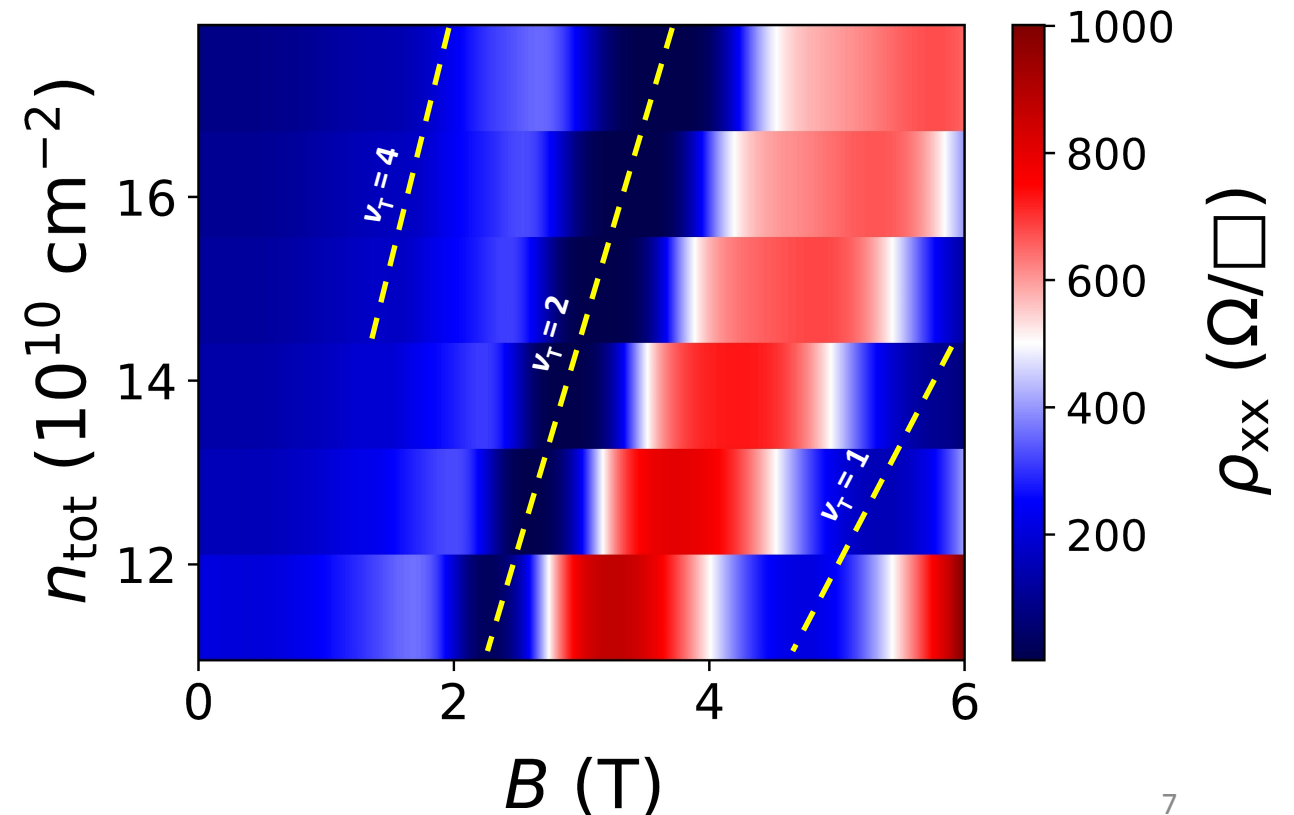
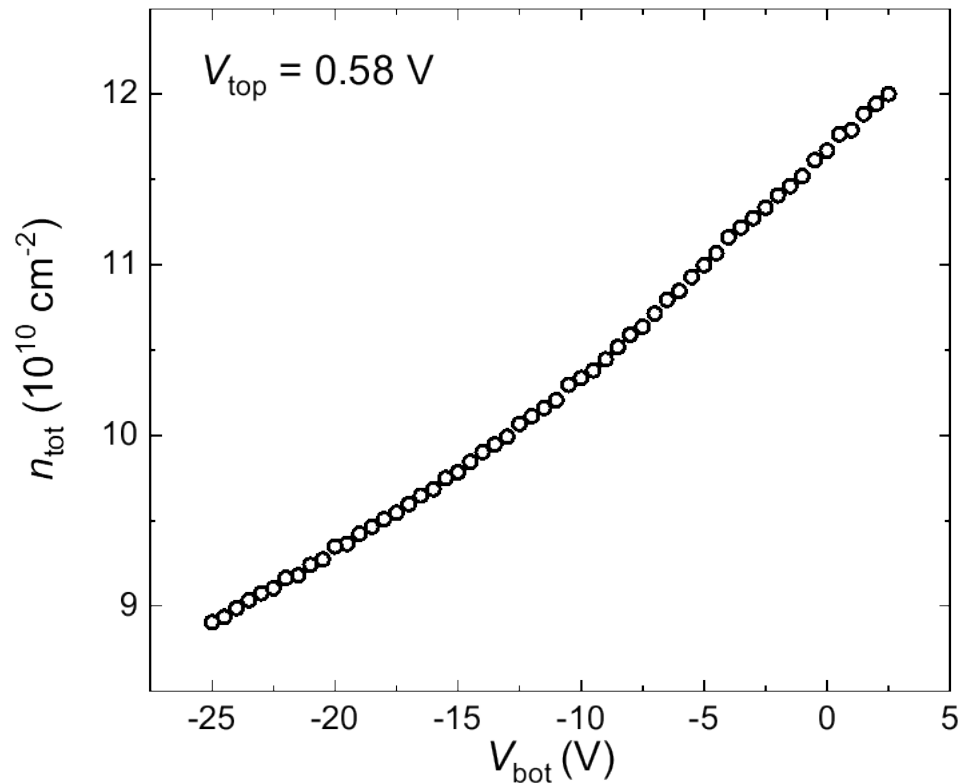
Front Gate – Variable Imbalanced Densities

- $\nu_T = 1, 2, 4$ ρ_{xx} minima evolves with n_{tot} and B
- $R_H = \rho_{xy} = R_K/\nu = h/e^2\nu$



Back Gate - Matched Densities

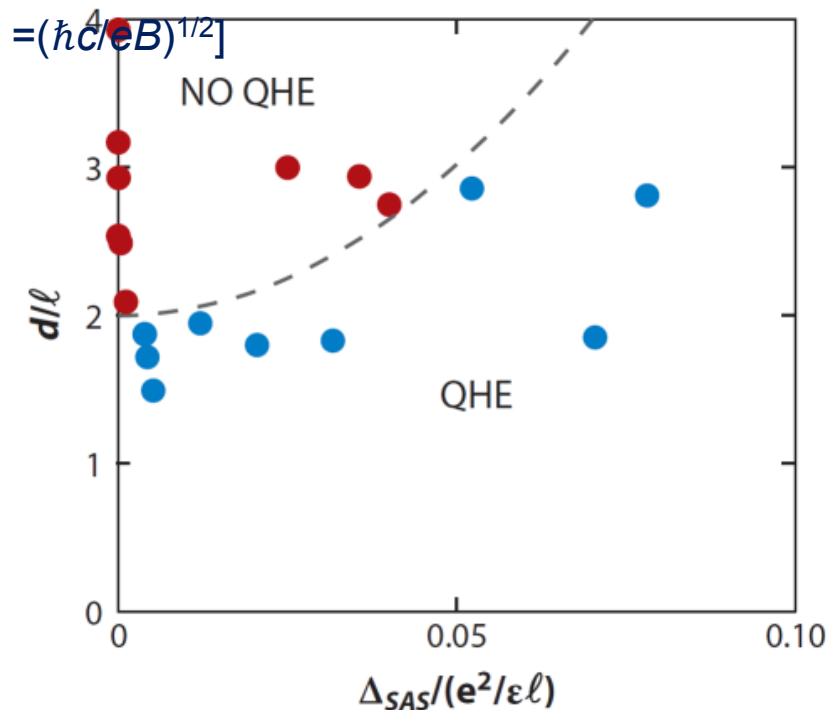
- Tuned back gate to achieve matched density
- Smaller range of available total densities possible
- $\nu_T = 1, 2, 4$ ρ_{xx} minima evolves with n_{tot} and B



Interlayer Effects

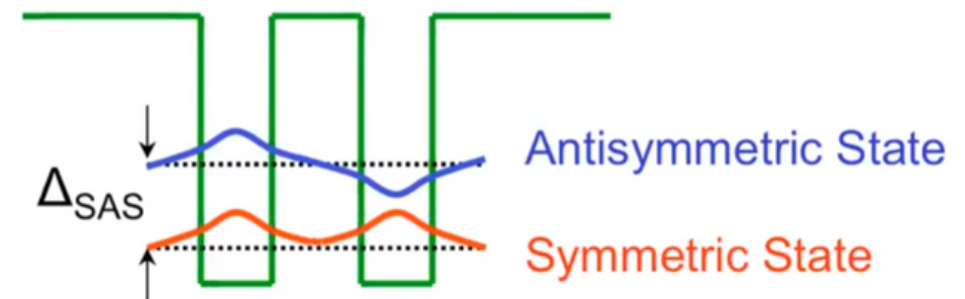
Spontaneous Interlayer Coherence

- Easy-plane ferromagnet or a Bose-Einstein condensate of excitons
- Quantum phase transition to a compressible state above some critical layer spacing, d_c/ℓ_b . [$\ell_b = (\hbar c / eB)^{1/2}$]



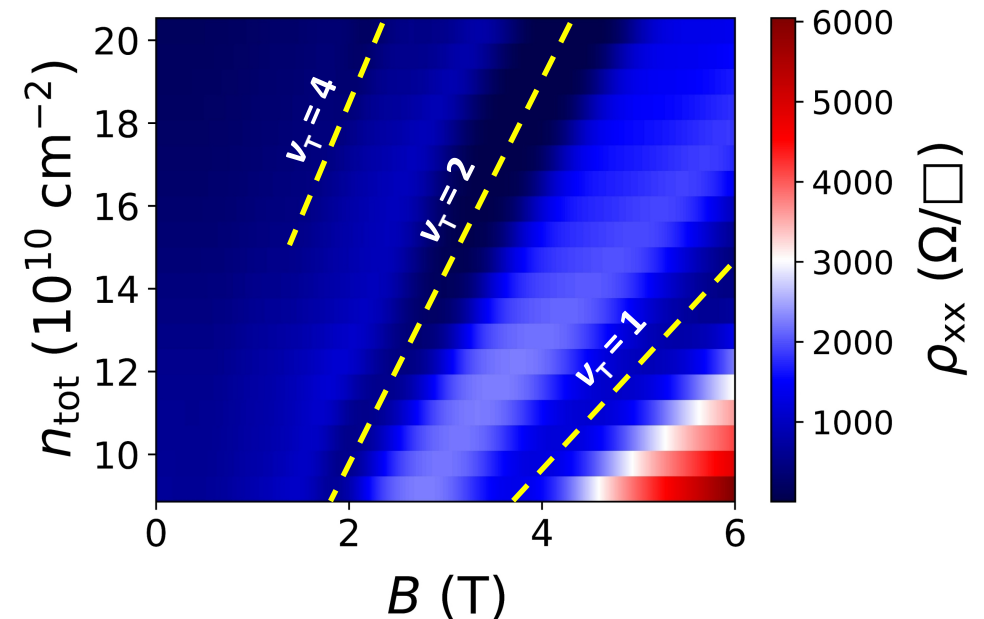
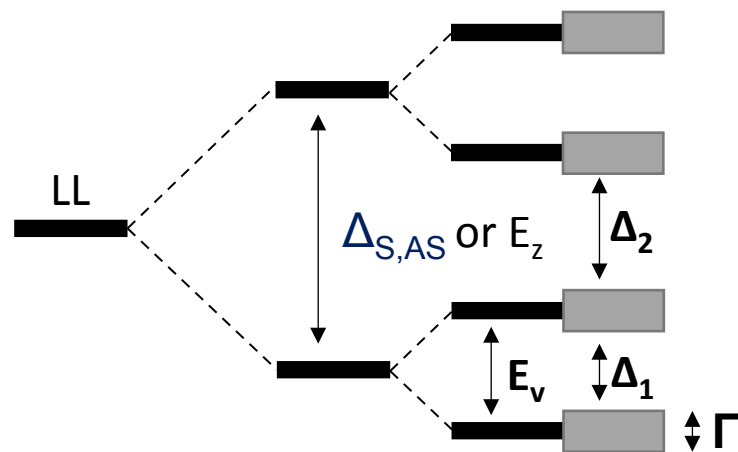
Single Particle Tunneling Gap

- When tunneling is sufficiently strong, $\Delta_{SAS} = \Delta_{AS} - \Delta_S$
- Δ_{SAS} decreases with increased barrier height and width



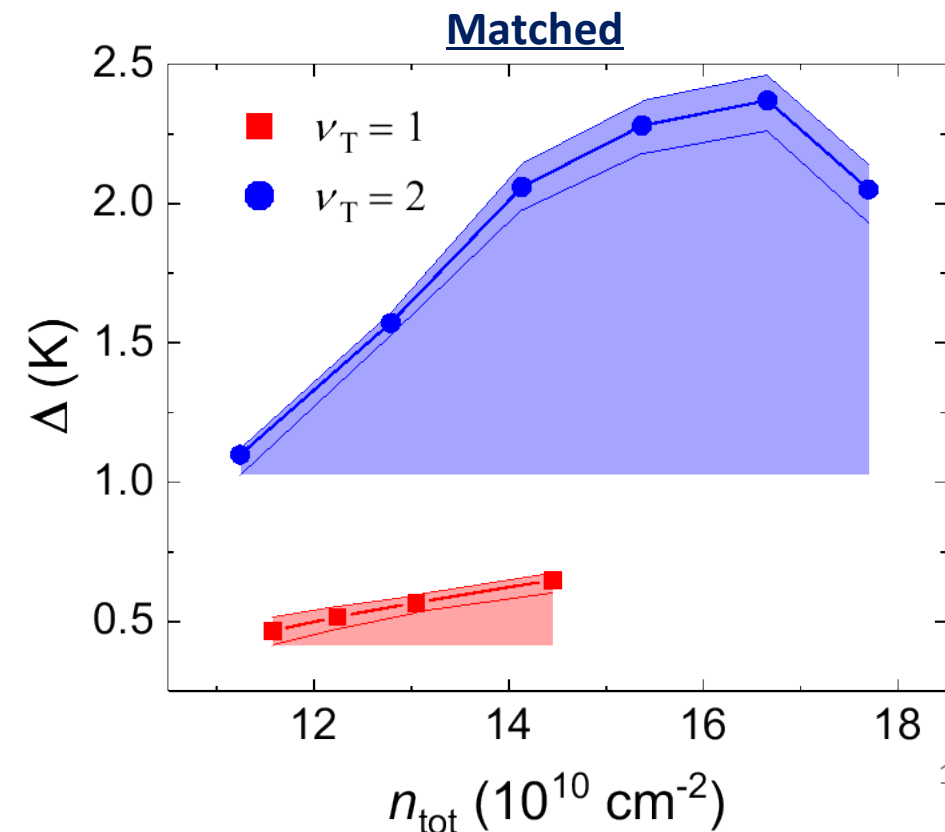
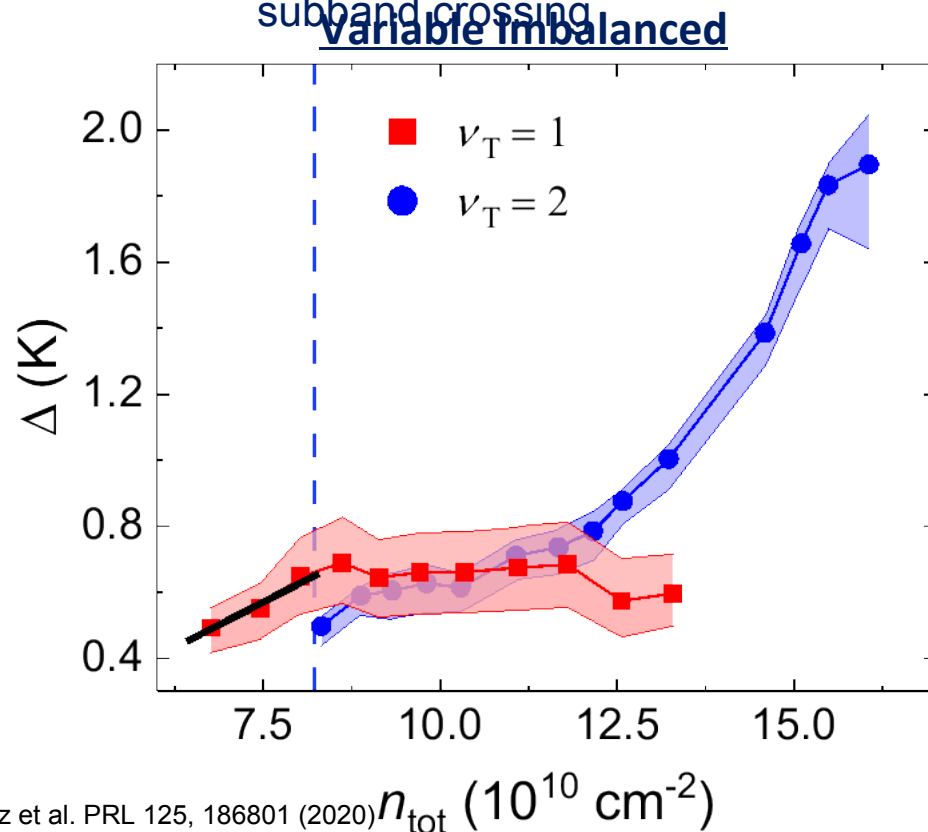
Degeneracies

- **Single layer regime:** spins ($\uparrow\downarrow$) and valleys (+/-)
 - Valley splitting and spin is linear with $n_{\text{tot}}(B)$
 - @ 4.13 T, $E_v \approx 1.35 \text{ K} < E_z \approx 2.79 \text{ K} \rightarrow v_T = 1$ ($v_T = 2$) attributed to valley (spin)
- **Bilayer regime:** layer (S/AS) degree of freedom
 - Single particle tunneling gap, Δ_{SAS} , can be estimated from SP
 - No LL crossing when transitioning into the bilayer state
 - $v_T = 1$ is attributed to valley
 - $v_T = 2$ is attributed to interlayer effects



Extracted Activation Gaps

- The activation gaps were extracted through temperature dependence scans
- Non-linear behavior for both $\nu_T = 1$ and $\nu_T = 2$ at variable imbalanced and matched densities
- Valley [1], spin and Landau gaps should evolve linearly to 1st order w/ B in the absence of subband crossing



Fan diagram generated by SP simulation: 4 energy sub-levels per LL since VS omitted

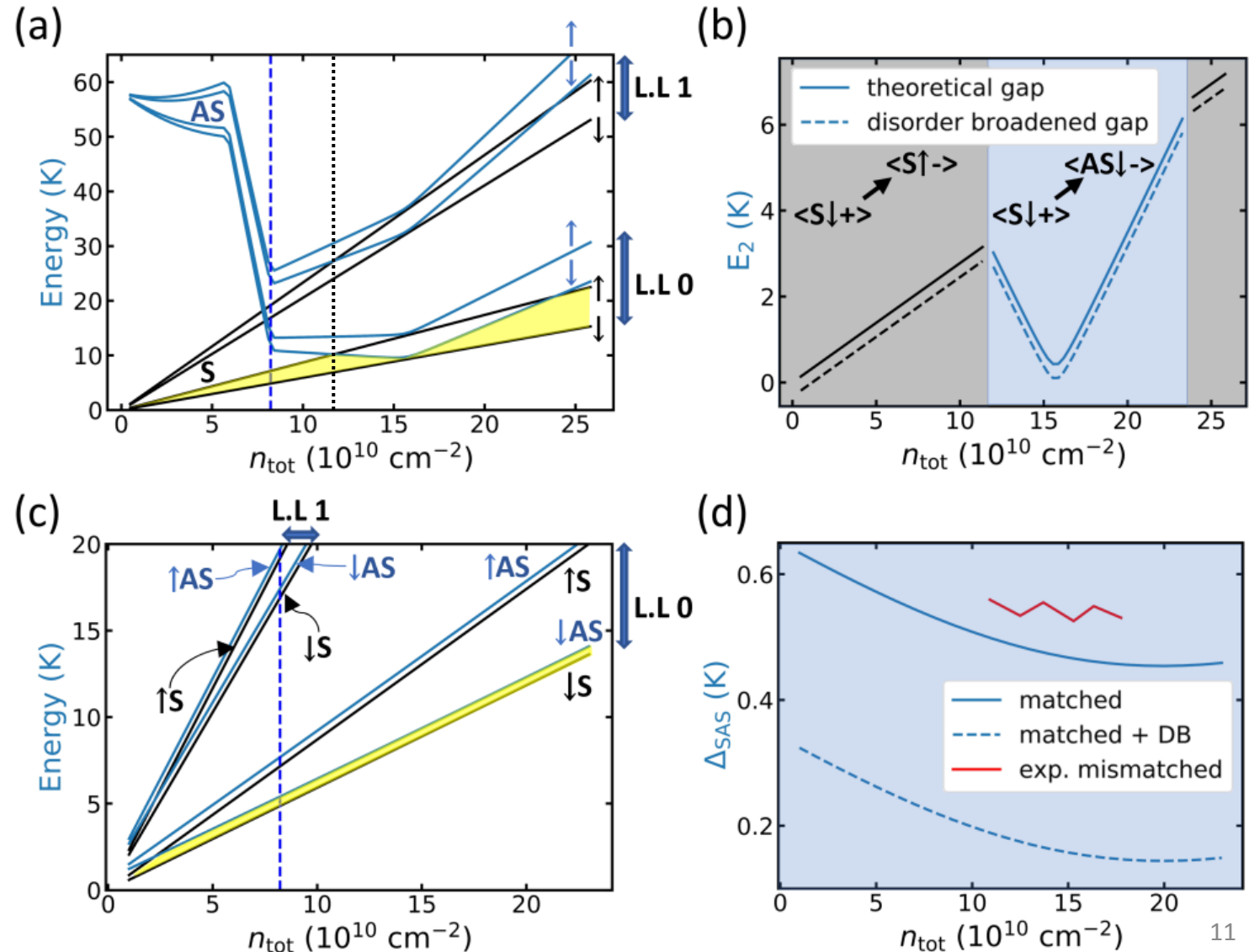
Variable Imbalanced

Densities:

E_z and Δ_{SAS}

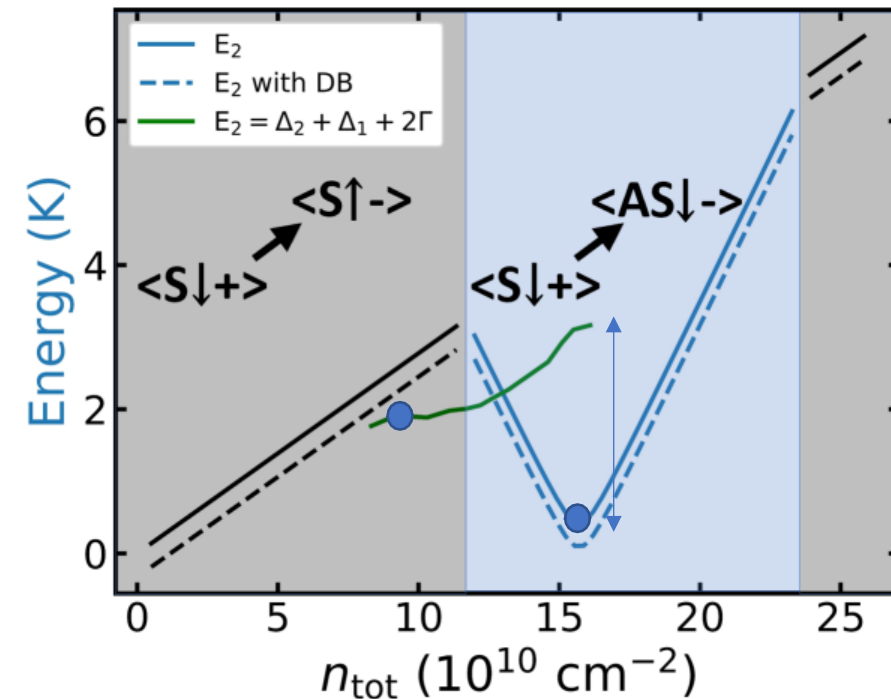
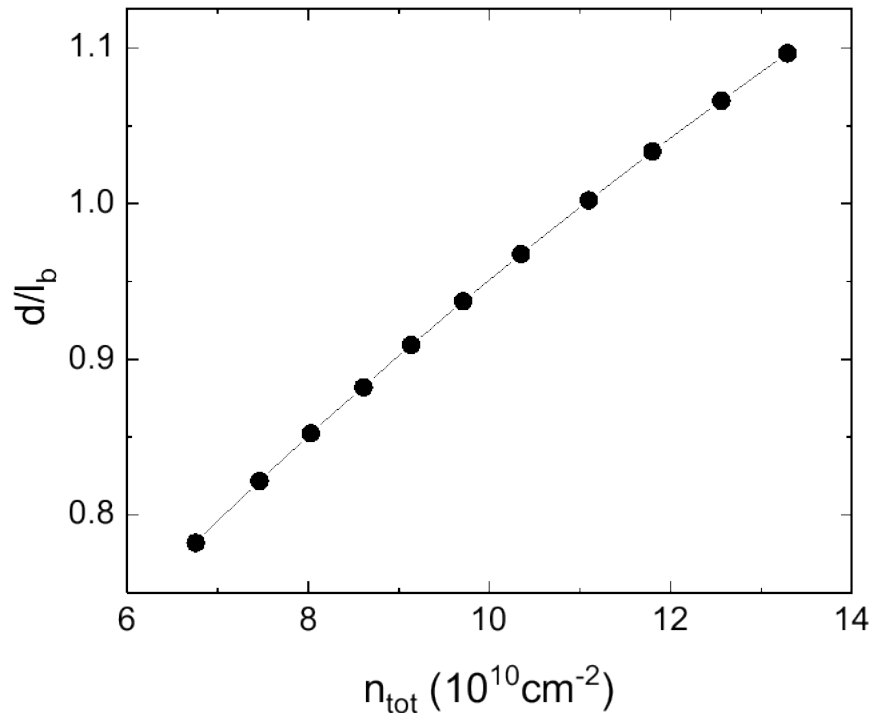
Matched Densities:

Δ_{SAS}



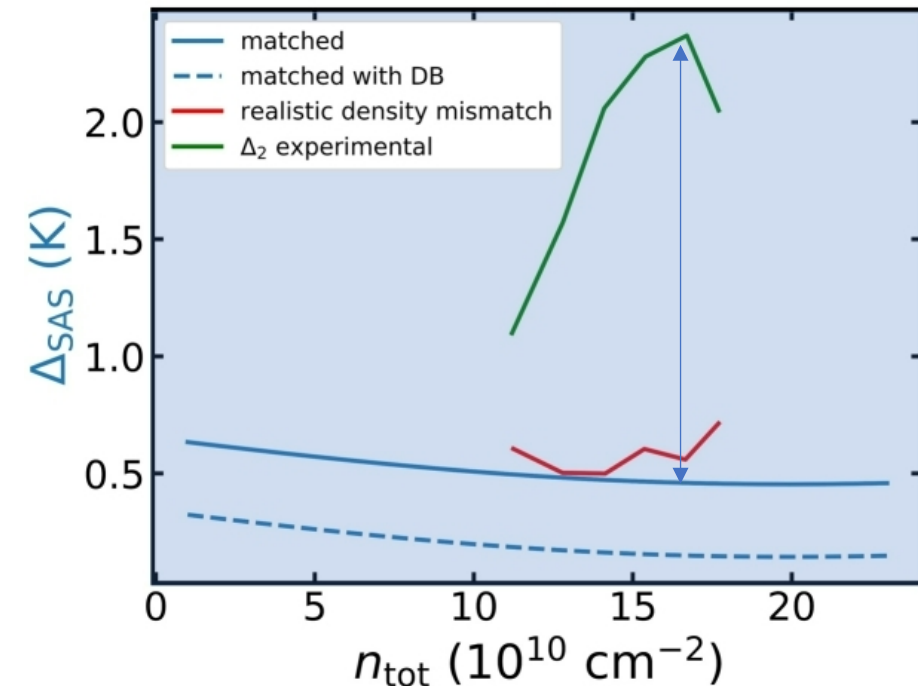
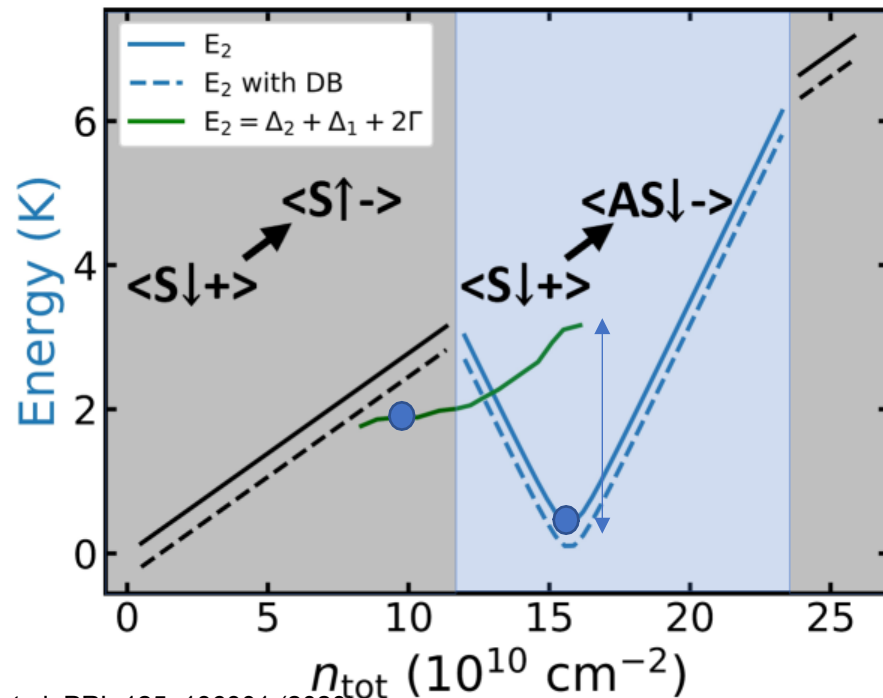
Interpreting $v_T = 2$

- Interplay between spin splitting and interlayer effects, Δ_{SAS} & SIC
- **Device:** $d/\ell_b = [0.62-1.24]$ & $e^2/\varepsilon\ell_b \approx 5 \times 10^{-4}$ indicating SIC is possible
- From theory, $\Delta_2 = E_2 - E_1 - \Gamma = E_2 - \Delta_1 - 2\Gamma$
- Δ_1 unknown at low $n(B)$



Interpreting $v_T = 2$

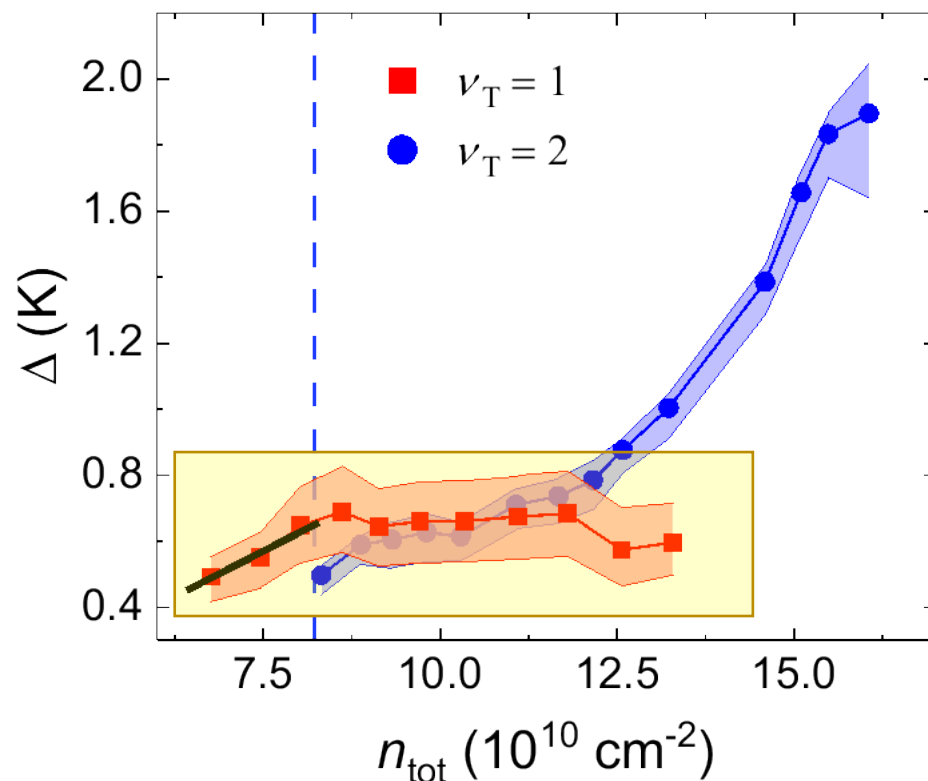
- Neither Δ_{SAS} , spin splitting, nor LL spacing alone reproduces Δ_2 .
- Strength of $\Delta_2 \uparrow$, induced by SIC:
 - $d/\ell_b \downarrow$
 - $\Delta v \uparrow$
 - $\Delta_{\text{SAS}} \downarrow$



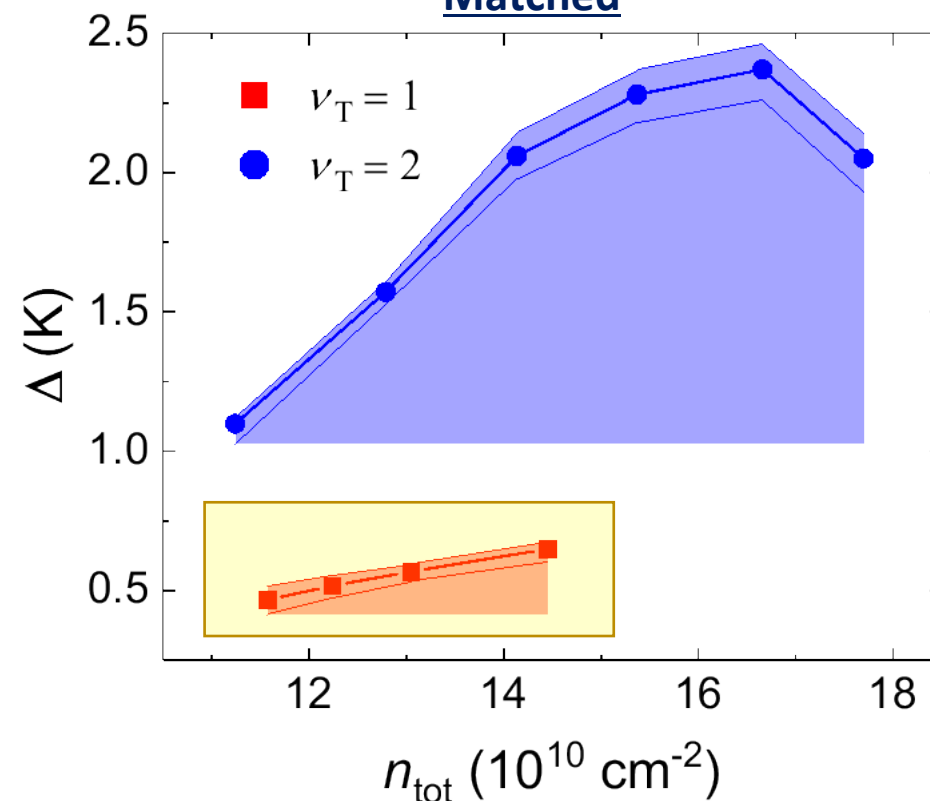
Valley Splitting & $\nu_T = 1$

- **Single Layer:** Disorder broadening, $\Gamma \approx 0.327$ K and linear coefficient, $c_B \approx 0.29$ K/T
 - $\Delta_v = E_v - \Gamma = c_B B - \Gamma$
- The bilayer dependence decreases and nearly flattens out (not understood)
- Si may exhibit large valley splitting at low B or spontaneous valley polarization

Variable Imbalanced



Matched



Thank you for your attention!

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Tzu-Ming Lu



**Center for Integrated
Nanotechnologies**

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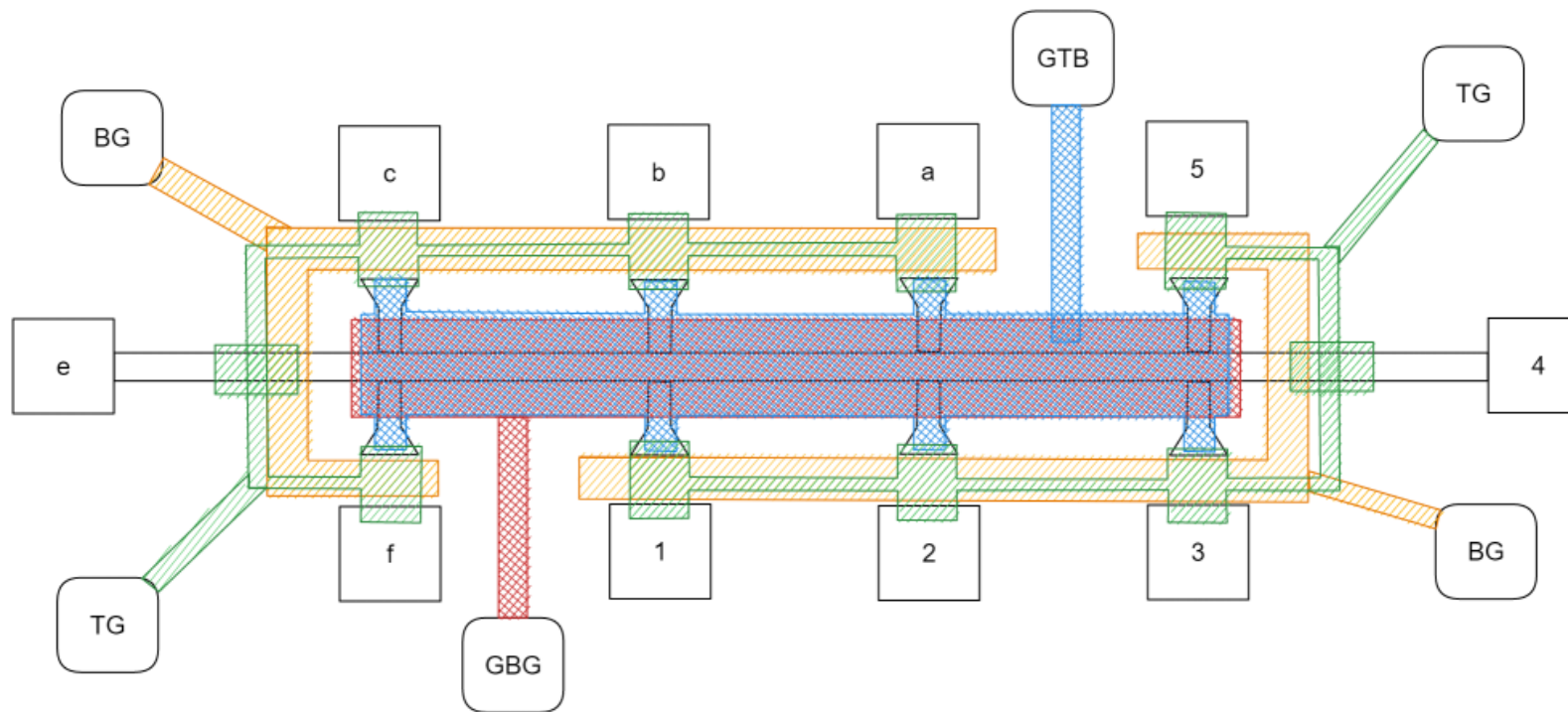


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Dual gated undoped Si/SiGe bilayer

Single & Bilayer quantum Hall states at $\nu_T = 1, 2$

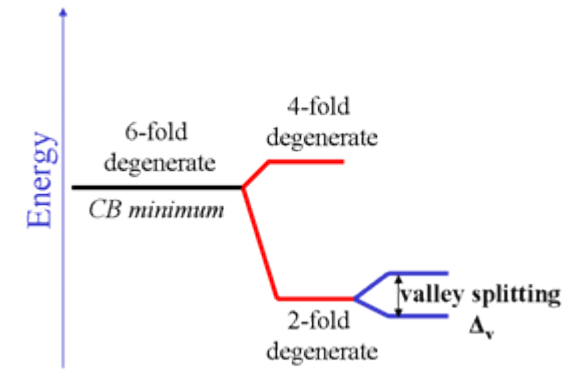
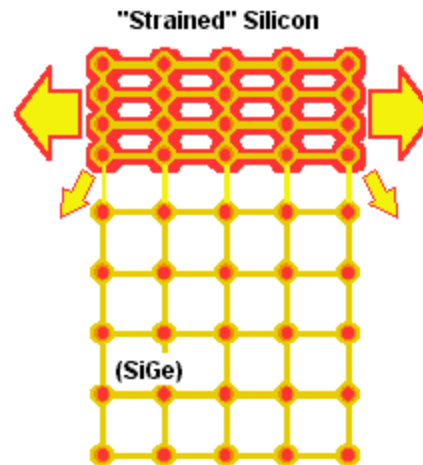
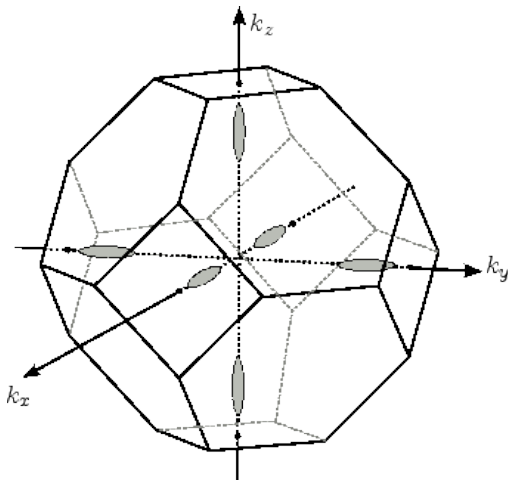
Evidence of Exciton Condensation warrants further investigation



Questions?

Valley Splitting in Single Layers

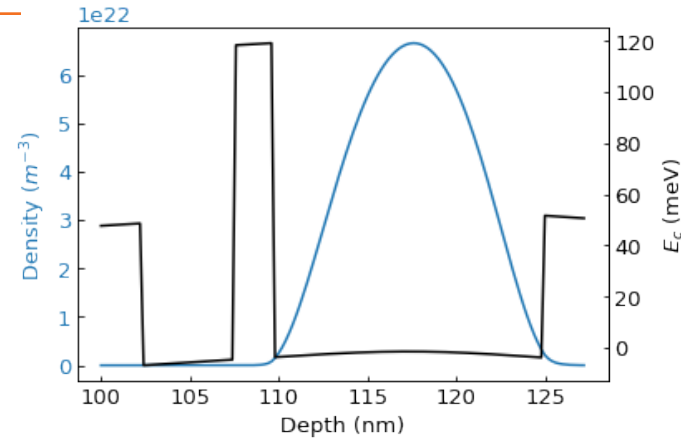
- In bulk Si, there is a 6-fold valley degeneracy
 - Tensile strain reduces it to 2-fold
 - Quantum confinement from the sharp quantum well interface lifts the degeneracy
- Atomic-scale disorder suppresses valley splitting
- Large valley splitting may be important for quantum computing



Achieving Matched Density

1. As V_{top} increased, n_{bot} increases until it saturates at $n_{\text{crossover}}$
2. n_{bot} stays constant past $n_{\text{crossover}}$ due to top layer screening
3. Now change V_{bot} (n_{top}^0 unaffected by V_{bot} due to bottom layer screening)
 - $n_{\text{top}}^0 = n_{\text{tot}} - n_{\text{crossover}}$
4. Thus, $n_{\text{bot}} = n_{\text{tot}} - n_{\text{top}}^0$

Matched density is achieved by collating the density dependence on the gates.

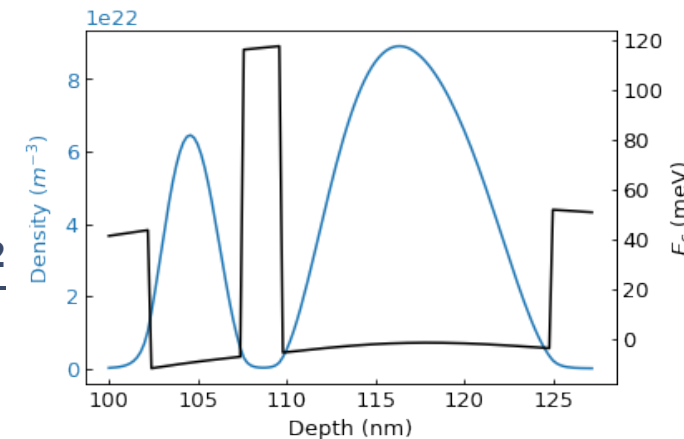


$$n_{\text{top}} = 2 \times 10^6 \text{ cm}^{-2}$$

$$n_{\text{bot}} = 6 \times 10^{10} \text{ cm}^{-2}$$

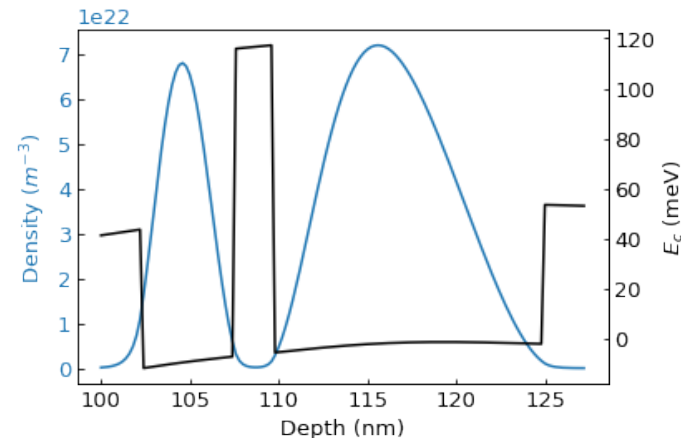
$$n_{\text{top}} = 2.1 \times 10^{10} \text{ cm}^{-2}$$

$$n_{\text{bot}} = 8.22 \times 10^{10} \text{ cm}^{-2}$$



$$n_{\text{top}} = 2.2 \times 10^{10} \text{ cm}^{-2}$$

$$n_{\text{bot}} = 6.12 \times 10^{10} \text{ cm}^{-2}$$



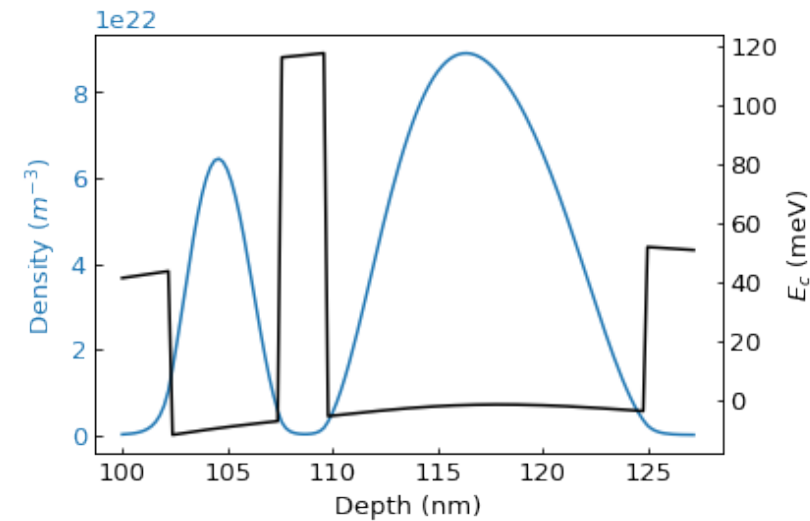
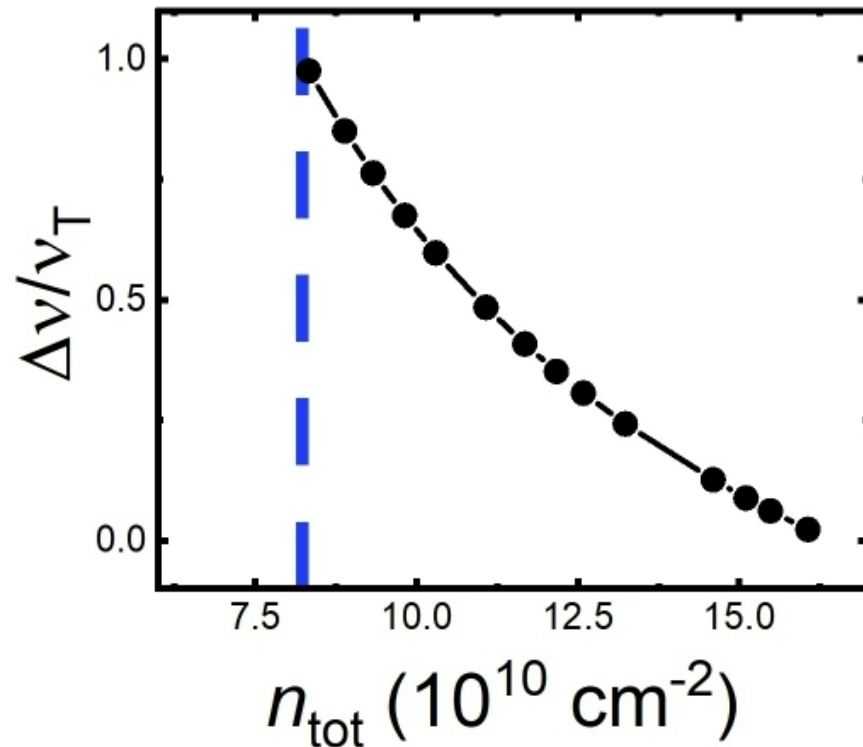
Achieving Matched Density

- As V_{top} increased, n_{bot} increases until it saturates at $n_{\text{crossover}}$
- n_{bot} stays constant past $n_{\text{crossover}}$ due to top layer screening (change V_{bot})
- $n_{\text{top}}^0 = n_{\text{tot}} - n_{\text{crossover}}$ (n_{top}^0 unaffected by V_{bot} due to bottom layer screening)
- Thus, $n_{\text{bot}} = n_{\text{tot}} - n_{\text{top}}^0$
- Matched density is achieved by collating the density dependence on the gates.

V_{top} (V)	V_{bot} (V)	n_{tot} (10^{10} cm^{-2})	n_{top} (10^{10} cm^{-2})	n_{bot} (10^{10} cm^{-2})	% Difference
0.62	-26.525	11.24	5.77	5.47	5.47
0.63	-18.976	12.79	6.43	6.36	1.22
0.64	-12.368	14.14	7.11	7.03	1.18
0.65	-6.375	15.37	7.84	7.53	4.04
0.66	-1.375	16.66	8.44	8.22	2.74
0.67	3.457	17.7	9.09	8.61	5.5
0.62*	-26.525*	11.57	5.77	5.8	0.53
0.625*	-22.613*	12.24	6.08	6.16	1.33
0.63*	-18.976*	13.05	6.43	6.62	2.76
0.64*	-12.368*	14.45	7.11	7.34	3.16

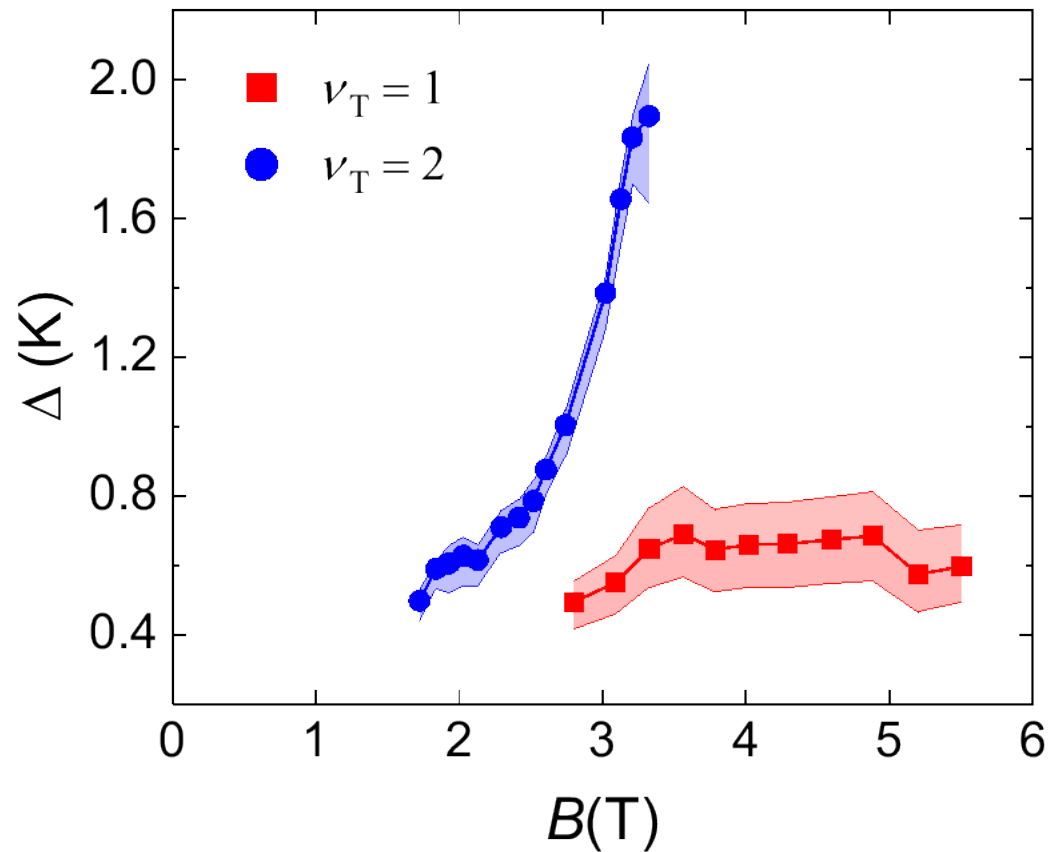
Density Imbalance

- $v_T = n_T/(eB/h)$ & $\Delta v = v_1 - v_2$
- $\Delta v/v_T = (v_1 - v_2)/2 \approx 0.5$ @ $n_{\text{tot}} = 11.07 \times 10^{10} \text{ cm}^{-2}$
- The onset of Δ_2 's magnitude increase coincides w/ $\Delta v/v_T \approx 0.5$

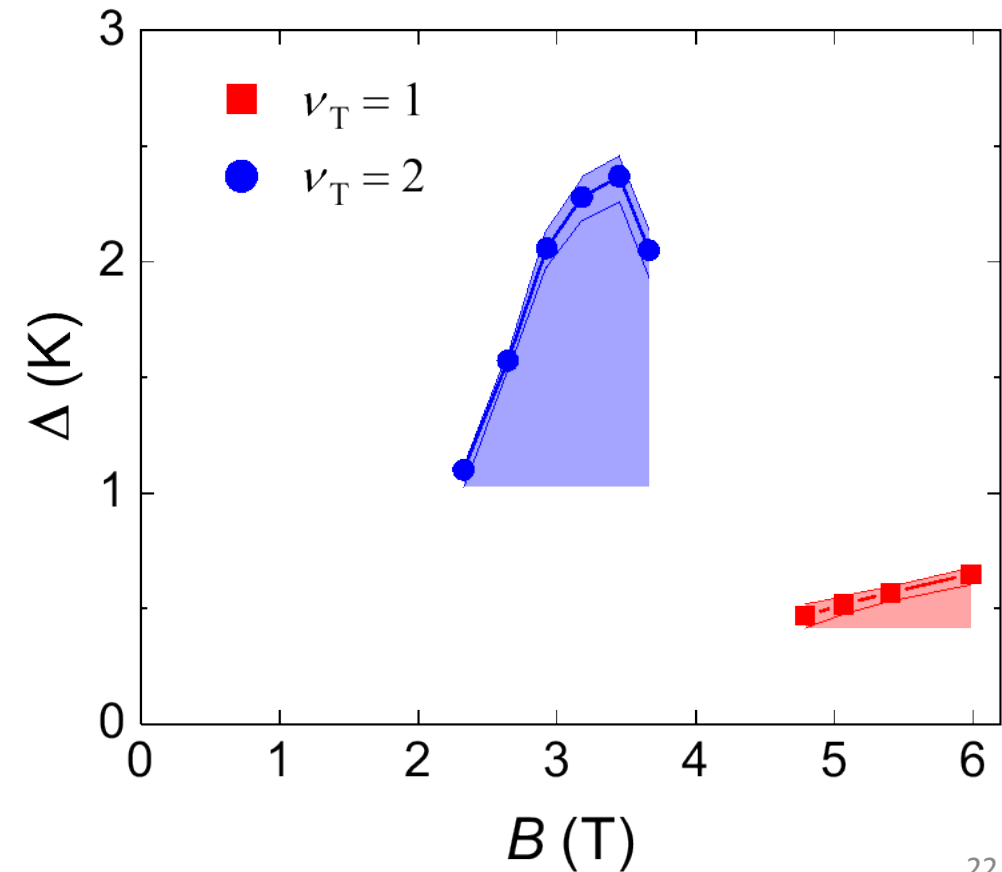


- $R_H = \rho_{xy} = R_K/\nu = h/e^2\nu$ (1980) [$\nu_T = n_T/(eB/h)$]

Variable Imbalanced



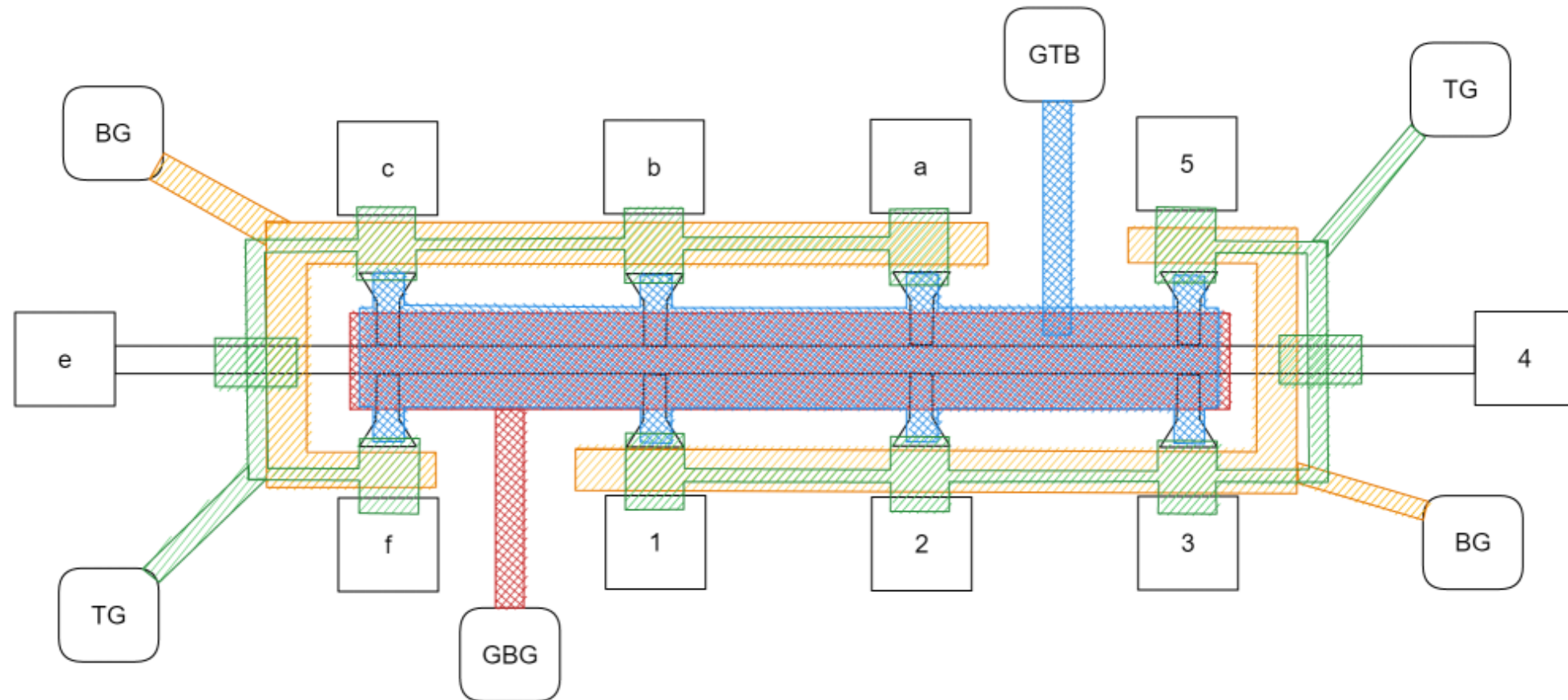
Matched



FUTURE WORK

Independent Contacts

- Designing a scheme to independently contact both layers simultaneously
- A combination of top/bottom accumulation gates + density gates
 - Global Top (Bot) Gate: Blue (Red) Contact Top (Bot) Gate: Green (Yellow)
- Unlocks tunneling conductance, Coulomb drag, and counterflow measurements



NRF Fabrication

- Measuring Si/SiGe devices over a larger density range
 - Reduce the distance between the bottom QW and the bottom gate
 - Utilizing larger magnetic fields
- Fabricating Ge/SiGe bilayer devices at NRF
 - EBASE^[1] technique (Tetramethylammonium hydroxide (TMAH))
 - Valley splitting dependence using a tilted magnetic field

